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Introduction

- ★ The pharmaceutical and medical device industries are developing new technologies and new techniques at an ever increasing rate. Regulatory requirements are being defined, implemented and audited more frequently.
- ★ Certain aspects of manufacturing and R&D require the use of cleanrooms and controlled environments. In order to comply with the various cleanroom and regulatory requirements facilities must have environmental monitoring programs.
- ★ This presentation will cover the various cleanroom standards as they relate to environmental monitoring programs and highlight the use of particle counters and their use and implementation in the pharmaceutical industry. Additional information is provided on the use of FMS system for pharmaceutical monitoring, their validation and compliance with various regulations.





Outline

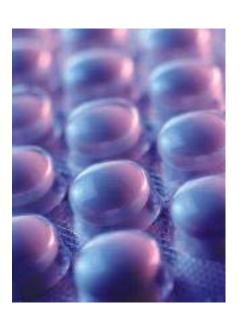
- ★ cGMP's and Regulations
- ★ Cleanroom Standards for Pharmaceutical and Medical Device Manufacturing and Explanation of Grades
- ★ The Purpose of an Environmental Monitoring Program
- ★ Regulatory Requirements
- ★ Recommendations for Microbial Contamination
- **★** What to Monitor





Current Good Manufacturing Practices

- ★ Umbrella GMPs, 21 CFR parts 210, 211
- ★ Biologics, 21 CFR part 600 series
- ★ Devices and Diagnostics, 21 CFR part 800 series
- ★ International GMPs
- **★** FDA Guidelines for Aseptic Processing
- **★** FDA Guidelines for Process Validation
- ★ FDA's "Points to Consider"
- ★ NIH Containment Guidelines
- **★** ISO 14644-1/FED-STD 209E







Application of Regulations

Pre-clinical Work

★ Material is Experimental with no GMPs applicable (Good Documentation Recommended)

Phase I Trails

★ Acute Toxicity to Animals and Then Very Preliminary testing of Healthy Volunteers: GMPs Apply for Raw Material Controls, Documentation, Analytical Methods etc.





Application of Regulations

Phase II & III

★ Compliance With Full GMPs and Validation

Production Phase

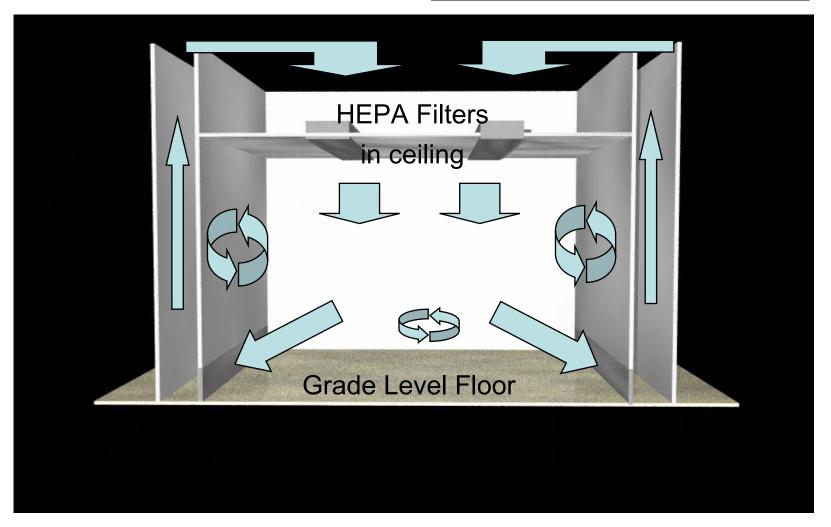
★ Compliance With Full GMPs and Validation







What Makes a Cleanroom Work? Conventional Cleanroom



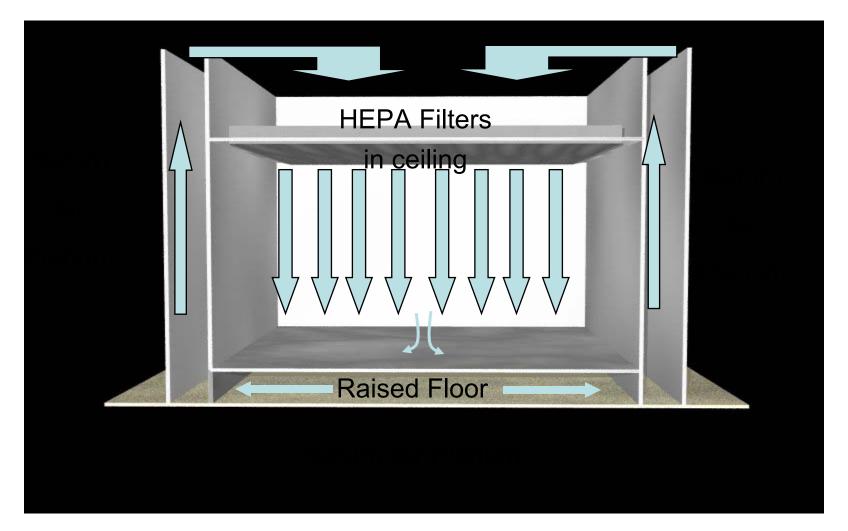
1) Control Of Incoming Air Volume (Dilution)

2) Filtration





What Makes a Cleanroom Work? Uni-Directional Cleanroom



1) Control Of Air Flow and Direction

2) Filtration





Cleanroom Standards

- **★ FED-STD 200E**
- ★ BC 5205
- **★ ISO 14644-1**
- **★** EU GGMP





Fed-Std 209 E

	FED-STD 209										
CLASS	NME	0.1μΜ		0.2μΜ		0.3μΜ		0.5μΜ		5.0 av1	
		VOLUME U	NITS	VOLUME	UNIT	VOLUME	EUNIT	VOLUME	UNIT	VOLUME	UNIT
S.I.	ENGLIS	(M)	(FT ³)	(M^3)	(FT ³)	(M^3)	(FT ³)	(M^3)	(F1)	(M^3)	(FT ³)
M1		350	9.91	75.7	2.14	30.9	0.875	10	0.283		
M1.5	1	1240	35	265	7.5	16	3	35.5	1		
M2		3500	99.1	757	21.4	309	8.75	100	2.83		
M2.5	10	12,400	350	2,650	75	1 060	30	353	10		
MB		35,000	991	7,570	214	3.00	87.5	1,000	28.3		
MB.5	100			26,500	750	10,600	300	3,530	100		
M4				75,000	2,140	30,900	875	10,000	283		
M4.5	1000							35,360	1,000	247	7
M5								100,000	2,830	618	17.5
M5.5	10000							353,000	10,000	2,470	70
M6								1,000,000	28,300	5 180	175
M6.5	150000							3,530,000	100,000	24,700	700
V 1/								10,000,000	283,300	61,800	17,500





Fed-Std 209 E

- ★ IEST WG 100 has recommended to the GSA (U.S. General Services Group) that they (GSA) "...discontinue the use and maintenance of FED-STD-209". The next step is for GSA to poll the U.S. Federal Agencies on the proposal that FED-STD-s09 be dropped and that the Federal Agencies use ISO 14644-1 and -2.
- ★ Many organizations refuse to change, stating the cost of document changes are too expensive to warrant replacement of the standard.
- ★ It is commonly accepted still in some facilites in the United States and in Asia.





BS 5295

Part 1: 1989 Appendix 3 - Designation of Environmental Cleanliness

The second secon									
Table 2. Requirements for controlled environment installations									
	Maxin	num permit	tted numbe	er of partic					
	(eq	ual to, or g	reater than	n, started s	ize)		Minimum pres	are difference*	
Class of						Maximum flood area per sampling position for	Between classified area and unclassified	Between classified area and adjacent area of lower	
environmental						clean rooms	l area	classification	
I all a secolitica a seco	0.0	0 =	-	40	AF				
cleanliness	0.3 μm	0.5 μm	5 μm	10 µr.	25 μm	m2	Pa	Pa	
cleanliness C	0.3 μm 100	35	5 μm 0	10**	1.0	m2 10	Pa 15		
_				10 un NS NS	25 μm NS NS	m2	Pa	Pa	
С	100	35	0	10**	1.0	m2 10	Pa 15	Pa 10	
C D	100 1000	35 350	0	NS	NS NS	m2 10 10	Pa 15 15	Pa 10 10	
C D E	100 1000 10000	35 350 3500	0	NS NS	NS NS	m2 10 10	Pa 15 15	Pa 10 10	
C D E F	100 1000 10000 NS	35 350 3500 3500	0 0	NS NS NS NS	NS NS NS	m2 10 10 10	Pa 15 15 15	Pa 10 10 10	
C D E F G	100 1000 10000 NS 100000	35 350 3500 3500 3500	0 0 0 200	NS NS NS NS	NS NS NS NS	m2 10 10 10 25	Pa 15 15 15 15	Pa 10 10 10 10	
C D E F G	100 1000 10000 NS 100000 NS	35 350 3500 3500 3500 3500	0 0 0 200 200	NS NS NS NS 0	NS NS NS NS NS	m2 10 10 10 25 25	Pa 15 15 15 15	Pa 10 10 10 10	
C D E F G H	100 1000 10000 NS 100000 NS NS	35 350 3500 3500 3500 35000 350000	0 0 0 200 200 2000	NS NS NS O 0 0 450	NS NS NS NS NS	m2 10 10 10 25 25 25	Pa 15 15 15 15 15	Pa 10 10 10 10 10 10	

^{*} This applies only to clean rooms and totally enclosed devices

^{*} NS: no specified limit

^{**} NA: not applicable as no limit specified





ISO 14644-1

Classification numbers	Maximum concentration limits (particles/m ³ of air) for particles equal to and larger than the considered sizes shown below						
	0.1 _µ m	0.2 _µ m	$0.3 \mu m$	$0.5 \mu m$	1 _µ m	5.0 _µ m	
ISO 1	10	2					
ISO 2	100	24	10	4			
ISO 3	1 000	237	102	35	8		
ISO 4	10 000	2 370	1 020	352	83		
ISO 5	100 000	23 700	10 200	3 520	832	29	
ISO 6	1 000 000	237 000	102 000	35 200	8 320	293	
ISO 7				352 000	83 200	2 930	
ISO 8				3 520 000	832 000	29 300	
ISO 9				35 200 000	8 320 000	293 000	





ISO 14644-1

- ★ The most international of all cleanroom standards. Has effectively replaced FED-STD 209E and BS 5295 (in the UK)
- ★ Some organizations refuse to change, stating the cost of document changes are too expensive to warrant replacement of the standard.





EU Guide to Good Manufacturing Practice

Manufacture of Sterile Medicinal Products

Maximum permitted number of particles / m³ equal to or above

at rest in operation

Grade	0.5μΜ	5μΜ	0.5μΜ	5μΜ
Α	3,500	0	3,500	0
B (a)	3,500	0	350,000	2,000
C (a)	350,000	2,000	3,500,000	20,000
D (a)	3,500,000	20,000	not definded (c)	not definded (c)

(c) The requirement and limit for this area will depend on the nature of the operations carried out.

⁽c) Notes:

⁽a) In order to reach the B, C and D air grades, the number of air changes should be related to the size of the room and the equipment and personnel present in the room. The air system should be provided with appropriate filters such as HEPA for grades A, B and C.

⁽b) The guidance given for the maximum permitted number of particles in the "at rest" condition corresponds approximately to the US Federal Standard 209E and the ISO classifications as follows: grades A and B correspond with class 100, M 3.5, ISO 5; grade C with class 10 000, M 5.5, ISO 7 and grade D with class 100 000, M 6.5, ISO 8.





EU GGMP Explanation of the Grades

For the Manufacture of Sterile Medicinal Products Normally 4 Grades Can be Distinguished.

★ Grade A: The Local Zone for High Risk Operations

- ★ Filling Zone
- ★ Stopper Bowls
- ★ Open Ampoules and Vials
- ★ Making Aseptic Connections
- ★ Normally Such Conditions are Provided by a Laminar Air Flow Work Station. Laminar Air Flow Systems Should Provide an Homogeneous Air Speed of 0.45 m/s +/- 20% (Guidance Value) at the Working Position.

★ <u>Grade B</u>: In Case of Aseptic Preparation and Filling

The background environment for grade A zone.

★ Grades C and D:

Clean areas for carrying out less critical stages in the manufacture of sterile products.





Recommendations for Microbial Contamination

Recommended limits for microbial contamination (a)								
GRADE	air sample cfu/m3	settle plates (diam. 90 mm), cfu/4 hours(b)	contact plates (diam.55 mm), cfu/plate	glove print. 5 fingers.cfu/glove				
A	< 1	< 1	< 1	< 1				
В	10	5	5	5				
C	100	50	25	-				
D	200	100	50	-				

Notes:

- (a) These Are Average Values.
- (b) Individual Settle Plates May Be Exposed For Less Than 4 Hours.
- (c) Appropriate Alert And Action Limits Should Be Set For The Results Of Particulate And Microbiological Monitoring. If These Limits Are Exceeded Operating Procedures Should Prescribe Corrective Action.





Examples of operations to be carried out in the various grades

Grade	Examples of operations for terminally sterilised products. (see par. 11)
Α	Filling Of Products, When Unusually At Risk.
С	Preparation Of Solutions, When Unusually At Risk. Filling Of Products.
D	Preparation Of Solutions And Components For Subsequent Filling.
Grade	Examples Of Operations For Aseptic Preparations. (See Par. 12)
Α	Aseptic Preparation And Filling.
С	Preparation Of Solutions To Be Filtered.
D	Handling Of Components After Washing.





Order of Risk Based on Route of Administration

- ★ Parenteral & Ophthalmic Products
- **★** Inhalation Solutions
- ★ Aerosol Inhalants
- ★ Nasal Sprays
- ★ Vaginal And Rectal Suppositories
- **★** Topicals
- **★** Oral Liquids
- ★ Oral Tablets & Capsules





The Purpose of an Environmental Monitoring Program

Human Drug cGMP Notes, March, 1999 states that the purpose is to:

- ★ Provides crucial information on the quality of the aseptic processing environment during manufacturing
- ★ Prevents the release of potentially contaminated batch if appropriate standards are not fulfilled
- ★ Prevents future contamination by detecting adverse trends





What are the Regulatory Requirements for Microbial Monitoring in a Pharmaceutical Manufacturing Area?









- ★ 21 CFR 211.42 Design & Construction Features
- ★ 211.46 Ventilation, Air Filtration, Air Heating & Cooling
- ★ 211.113 Control of Microbiological Contamination
- ★ 211.22 Responsibilities of the quality control unit







- ★ FDA Guideline on Sterile Drug Products Produced by Aseptic Processing, June 1987
- ★ FDA Guide to Inspection of Sterile Drug Substance Manufacturers, July 1994
- ★ EU Guide to Good Manufacturing Practice. Annex on the Manufacture of Sterile Medicinal Products, June 1997



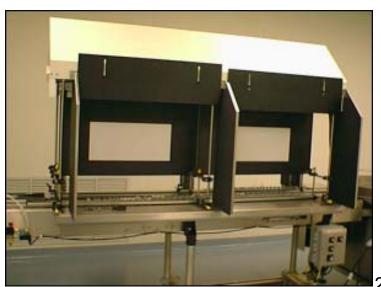




21 CFR 211.42

Design & Construction Features highlights that buildings used to manufacture pharmaceutical products shall be of suitable size, construction & location to facilitate cleaning, maintenance and proper operation.









21 CFR 211.42 (Cont)

Aseptic processing requires floors, walls & ceilings of smooth, hard surfaces that are easily cleaned, temperature & humidity controls, HEPA-filtered air, systems for environmental monitoring, cleaning & disinfecting, & maintaining the controlled environment.





21 CFR 211.46

Ventilation, Air Filtration, Air Heating & Cooling (b) requires equipment for adequate control over microorganisms for the manufacture, processing, packaging or holding a drug product.





21 CFR 211.113

Control of microbiological contamination. Requires that appropriate written procedures, designed to prevent the objectionable organisms in non-sterile drug products and microbiological contamination of sterile drug products, be established and followed. Such procedures shall include the validation of any sterilization process.





21 CFR 211. 22

Responsibilities of the Quality control unit.

Requires that the quality control unit monitor & ensure ongoing control of an aseptic process with the responsibility of approving or rejecting all drug products manufactured.





FDA Guideline on Sterile Drug Products Produced by Aseptic Processing, June 1987

Guideline suggests that a clean room air quality of not more than 0.1 colony-forming unit (CFU) per cubic foot in a Class 100 aseptic process area is reasonable.





EU Guide to Good Manufacturing Practice. Annex 1 on the Manufacture of Sterile Medicinal Products, 1997

Recommends limits for environmental monitoring that differ from the USP





Industry Practice

- ★ PDA Technical Report No. 13 Fundamentals of a Microbiological Environmental Monitoring Program
- ★ *PhRMA Task Force Report on Environmental Monitoring in Non-Sterile Manufacturing Areas.
- ★ BS 5295 Classification, Design & Commissioning Cleanrooms
- ★ US Federal Standard 209E for Cleanrooms
- ★ ISO and BS 14644 for Cleanrooms
- *Pharmaceutical Research and Manufacturers of America (PhRMA)





Difference between US and European Practices - Class 100

- **★** US monitors during each operating shift
- ★ For Grade A aseptic preparation & filling the EU recommended limits as average values are:
 - <1 cfu per m³ of air
 - <1 cfu per 4 hour on a 90 mm settling plate
 - <1 cfu per 55 mm contact plate
 - <1 cfu for a 5 finger glove print





Setting Limits and Trend Analysis

- ★ Limits Would Be Consistent With Regulatory Guidelines
- ★ Alert Limits Should Be Set From Monitoring Histories At The 95% Percentile
- ★ With >98% Of The Samples Taken Containing No Microorganisms, Limit Setting & Trend Analysis Is More Difficult
- ★ Reaction Should Be To Consecutive Out-of-limit & Not Individual Results





Timing of Microbial Monitoring

The Air And Surface Monitoring Should Be Conducted Actively During The Aseptic **Processing Operation With Personnel** Monitoring When The Operator Leaves The Process Area. An Exception Would Be The Monitoring Of Product Contact Surfaces Which Would Be Monitored At The End Of The Filling Operation.





Environmental Monitoring Program

- **★** Surface Monitoring
- **★** Active Air Monitoring
- ★ Passive Air Monitoring
- ★ Microbiological Media and Identification
- **★** Particle Counting





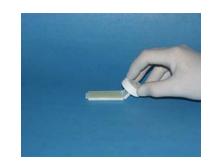
Surface Monitoring

Testing Various Surfaces for Microbiological Quality:

- **★** Product Contact Surfaces
- **★** Floors
- **★** Walls
- **★** Ceilings

Testing Carries Out By Using:

- **★** Contact Plates
- ★ Touch Plates
- **★** Swabs
- ★ Surface Rinse Method







Active Air Monitoring

Method to Determine the Microbial Quality of the Air Using Active Devices Such as:

- ★ Slit to Agar
- ★ Membrane Filtration
- ★ Centrifugal Samplers

All Allow a Quantitative Testing of the Number of Organisms per Volume of Air Sampled









Passive Air Monitoring (Settling Plates)

- ★ Petri Dishes Containing
 Nutrient Growth Medium
 Exposed to the Environment
- ★ Lack Quantitative Value (Only What Settles On Plate)
- ★ Qualitative Value Important As Can Be Placed In Locations With The Greatest Risk







Microbiological Media and Identification

- ★ Routine Characterization of Recovered Microorganisms
- ★ Monitoring of Critical and Surrounding Areas
- ★ Monitoring of Personal
- ★ Should Require Identification of Species or Genus
- The Goal Is To Reproducibly Detect Microorganisms For The Purpose Of Monitoring Environmental Control





Particle Counting

- ★ Useful in detecting significant deviations in air cleanliness from qualified processing classifications
- ★ Immediate understanding of air quality can be realized
- ★ Useful as a tool for qualification and monitoring before / during and after operations





Particle Counter Theory of Operation

There are three basic elements in all particle counting systems:

1) The Sensor

The Sensor Is The Device That Detects Particles Using A Light Scattering Techniques.

2) The Sample Delivery System

The Air Sample is Delivered the Sensor by Some Method.

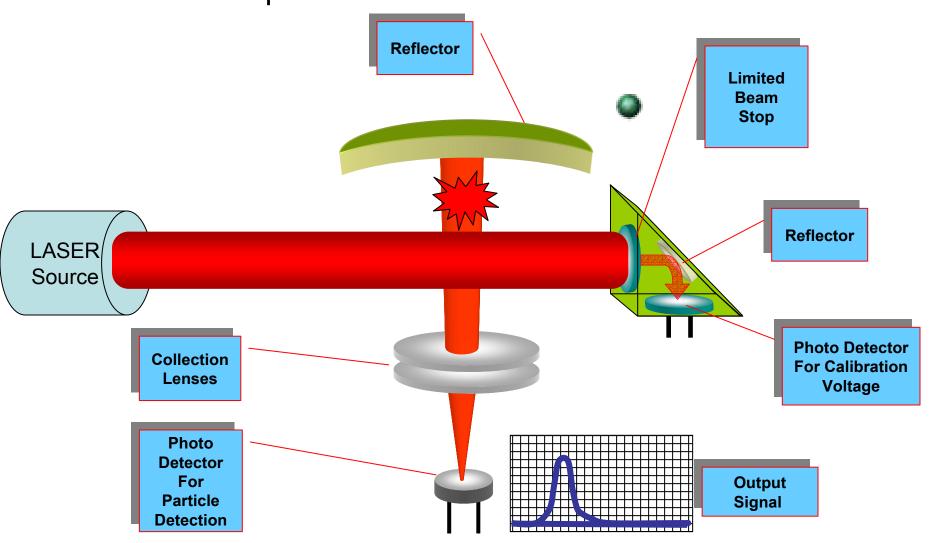
3) The Counting Electronics

The Particle Counts Are Processed And Displayed By "On Board" Circuitry Or In Software In Facility Monitoring Systems (FMS).





Particle Counter Operation

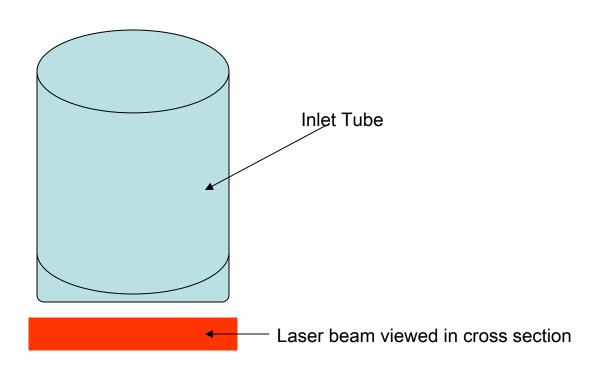






Sensor View Volume

The View Volume is
The area where the
air stream and the
laser beam intersect.
The View Volume is
the width of the inlet tube
and <u>+</u> 1mm high.



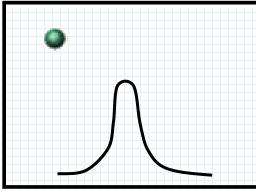




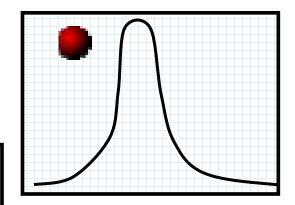
Particle Sizing

The larger the particle, the larger the corresponding output pulse from the sensor.

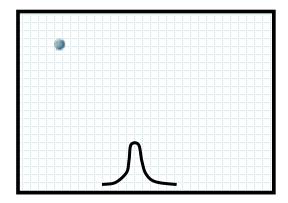
Larger



Largest



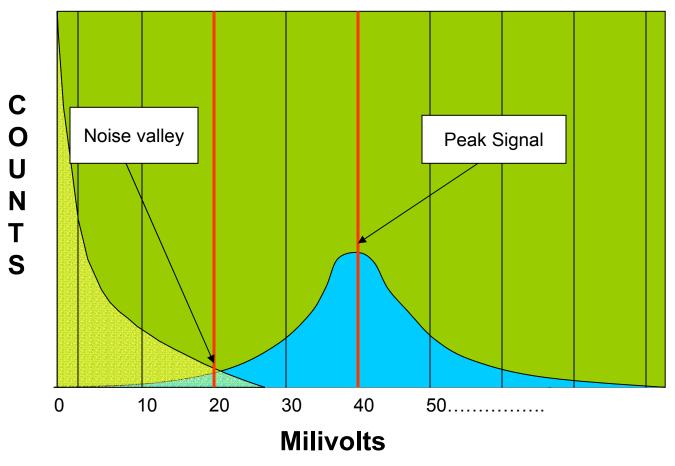








Signal To Noise Ration

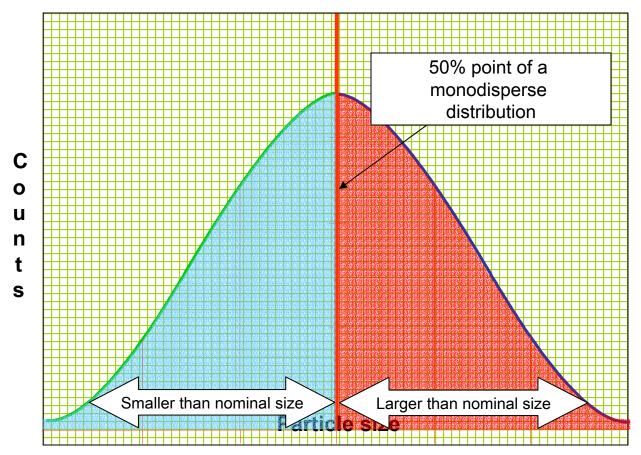


In accordance with the Japanese Industrial Standard (JIS) the minimum Signal to Noise Ratio is 2 to 1.





50% Counting Efficiency



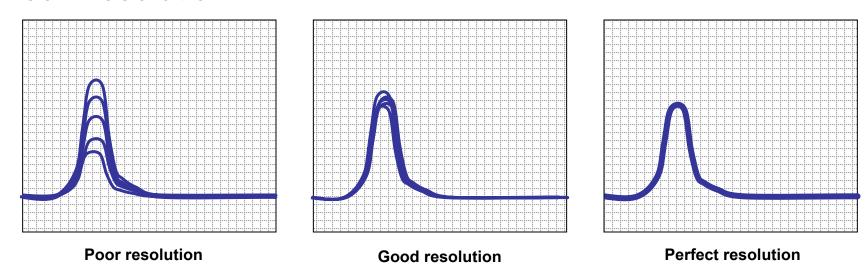
Definition: In a monodisperse distribution, the sensor detects all particles at the nominal size and larger.

JIS requires that the counting efficiency of the smallest detectable size of a sensor be between 30 and 70%.





Sensor Resolution



Causes of poor resolution:

Contamination. A buildup of particles in the sensor can disturb the light path.

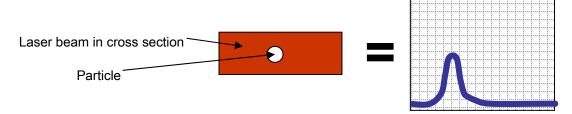
Misaligned sensor. A misaligned sensor must be returned to the factory for alignment.

Failing laser diode. This sensor must also be returned to the factory for diode replacement.





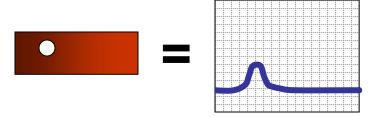
Why "perfect" resolution can not be achieved.



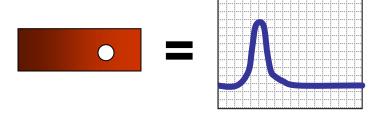
The above laser beam has uniform light intensity across the entire width.

Wherever a particle enters the beam the output pulse is the same.

This can not be achieved due to slight flaws in the optics and laser diode.



In this example a particle has entered the laser beam in an area of lower light intensity. The resulting output pulse is low.



Note: These examples assume uniform sized particles

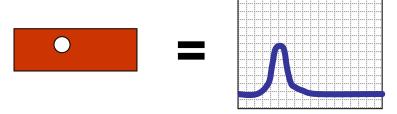
In this example the particle has entered the higher intensity area of the beam and the output pulse is higher in amplitude.



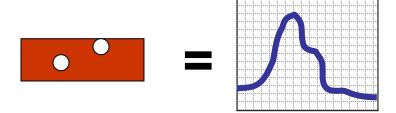


Coincidence Error

If particle counter is used in environments where the concentrations of particles are too high more than one particle at a time can enter the view volume. This results in coincidence errors.



In this example shows one 0.5µ particle in the view volume and it's output pulse.



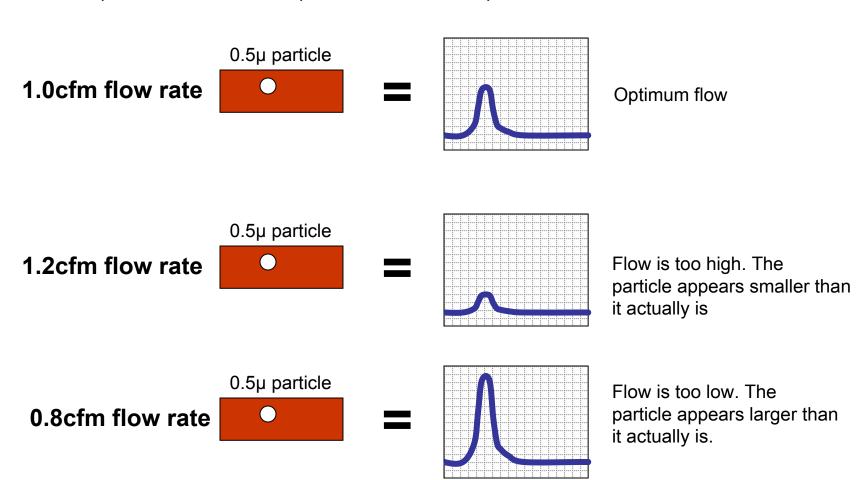
This example shows two 0.5µ particles in the view volume at the same time. The counter would report a size larger than 0.5µ and only one count.





Effects of Flow on Sizing

The amplitude of the sensor output is a function of the particle's residence time in the view volume.







Sample Delivery

A vacuum pump is used to pull the sample air through the sensor. The flow is measured in cubic feet per minute (cfm). The use of some type of flow control is required to maintain the correct flow.

1.0 cfm pump



0.1 cfm pump



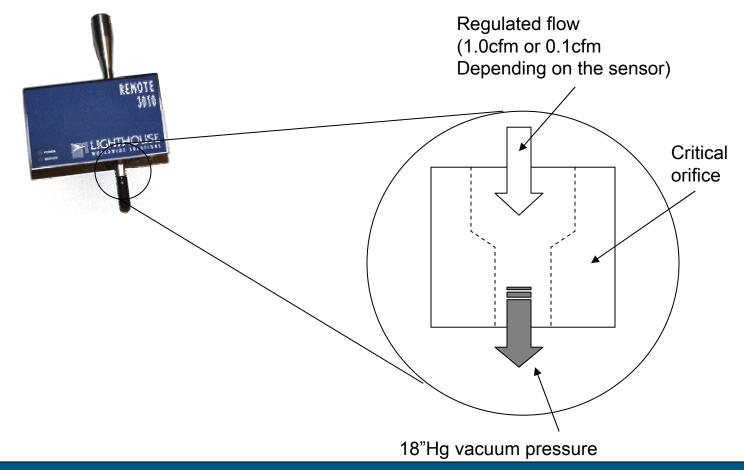




Critical Orifice

In remote counters a critical orifice is used to regulate the flow through the sensor. A critical orifice is a precision opening that will only allow a certain amount of air flow once the critical vacuum pressure is applied.

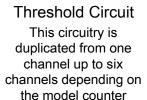
In the case of Lighthouse counters the critical pressure is 18"Hg.

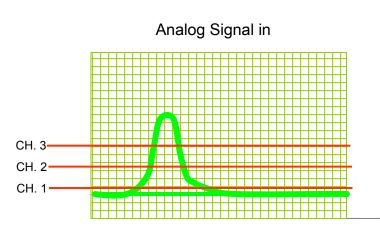


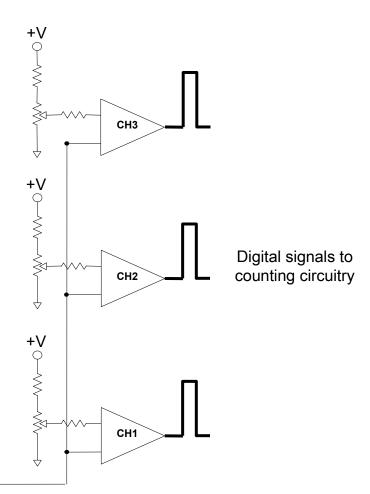




Counting Electronics



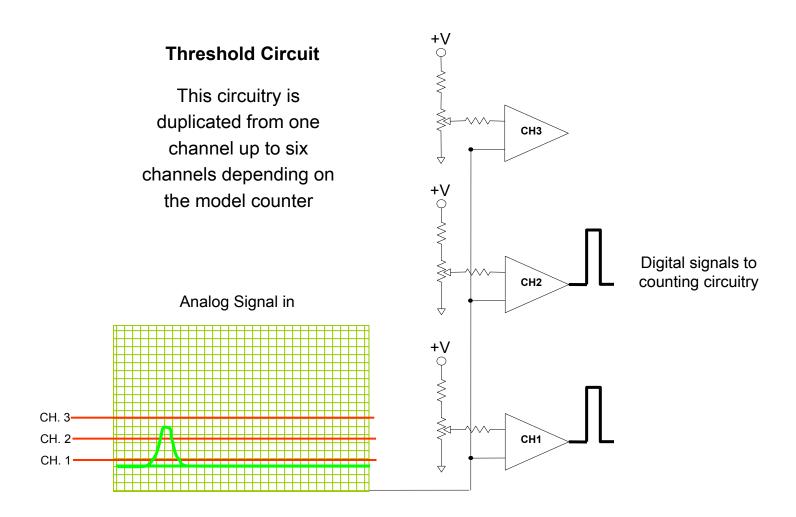








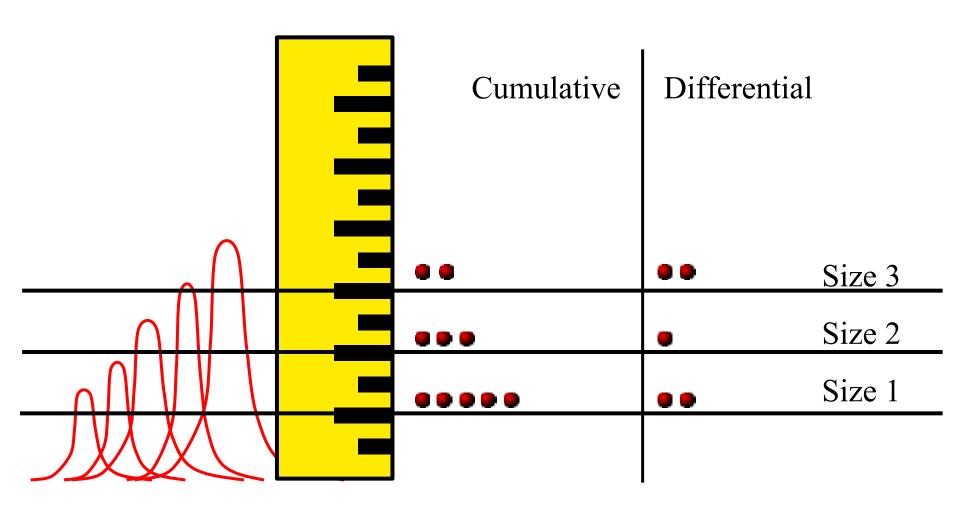
Counting Electronics cont.







Counting Modes (Cumulative vs. Differential)





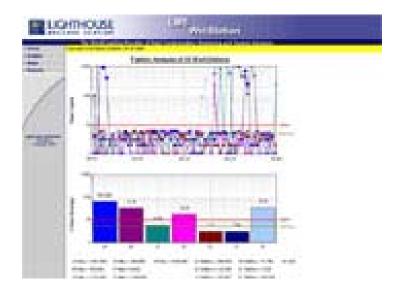


Data Display Modes (Printed vs. Electronic Records)

	SYSTEM STATUS	
TIME =	08:30:53 AUGUST	12,1999

PARAMETER	STATUS	VALUE		
SENSOR CAL	PASS	1.01 V		
Clock Battery	PASS	3.33 V		
+5 Volt PS	PASS	4.95 V		
+12 Volt PS	PASS	11.87 V		
-12 Volt PS	PASS	-12.20 V		
18v Battery	PASS	23.31 V		
Flow	PASS	0.98 V		
2094057-10				

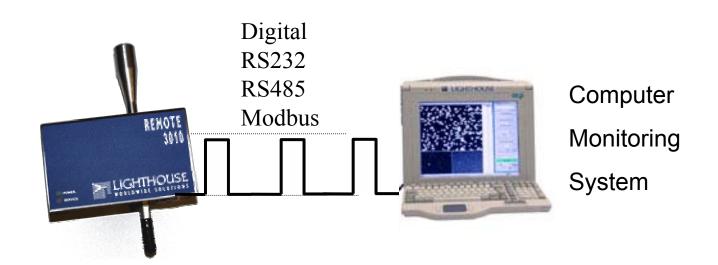








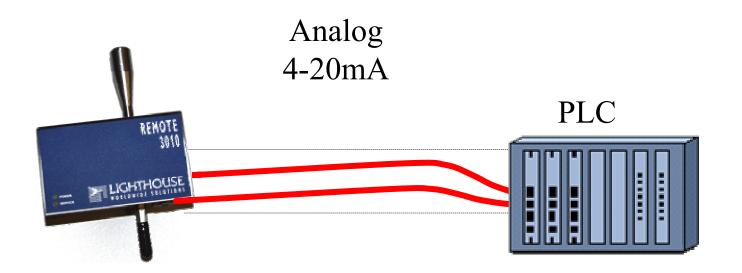
Remote Communication Modes







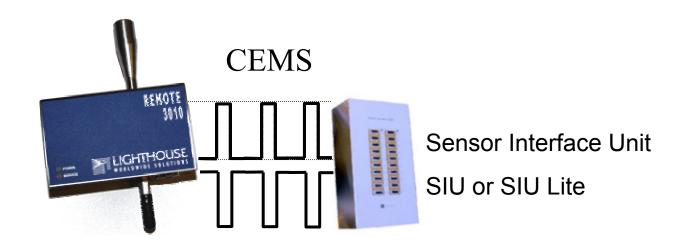
Remote Communication Modes







Remote Communication Modes







Particle Counting: Manual

Manual Particle Counting

★ Lowest Cost

Purchase

Service

Calibrate

- **★** Routine Tests For Compliance
- **★** Finding Contamination Sources
- ★ Used To Identify Sensitive Locations For Continuous Monitoring







Particle Counting: Extended Sampling

Manual Particle Counting

- ★ Program and "Forget"
- ★ Good for Long Term Testing
- **★** Flexible
- ★ Better Then Periodic Testing When Issues Arise







Portable Particle Counters

- □ Variety of Manufactures
- Tethered or Battery Operated Options
- Typically Higher Flow Rates (1 CFM)
- Built In Printers / Data Storage
- Some Units are "Manifold Ready"





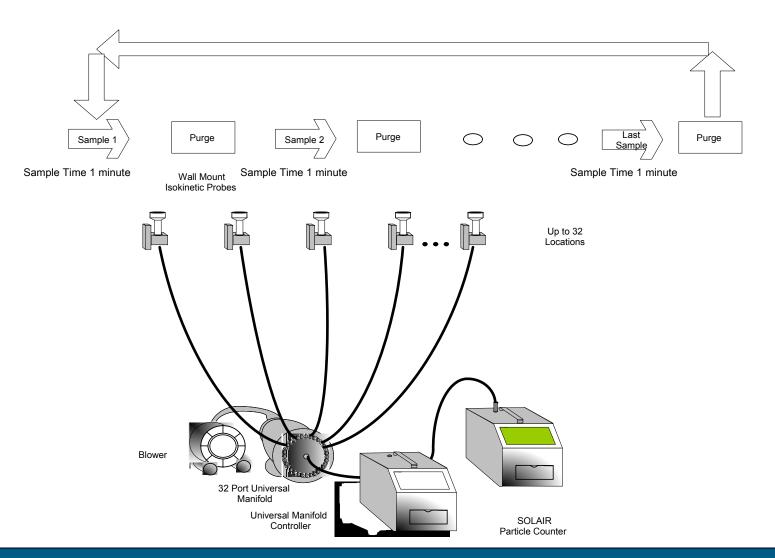
Automated Sequential Particle Counting

- A. Automated Tests For Compliance
- B. Up to 32 Points / Particle Counter (in sequence)
- C. Sensitivity 0.1 micron
- D. Time Between Particle Counts (same location) Based Upon The Number of Points Sampled by the Counter
- E. Episodes Of Particle Excursions Can Be Missed





Sequential Particle Counting System Operation: (Manifold or Scanner)







Sequential Sampling Particle Counting Systems:

- ★ Variety of Manufactures
- ★ Lower Cost / Point (Higher Sensitivity Possible)
- ★ Monitor Up To *32 Points With A Single Counter
- ★ Maximum Time To Re-Sample Is Dependent On Number of Points
- ★ Connection To External System Easy
- **★** Lower Calibration Cost
 - * Manufacturer Dependant





Manifold Points vs. Samples / Day

Number of Ports Samples	* Time between Samples at the same location	* Number of samples per day at same location
10 Ports	11 Minutes 40 Seconds	123 Samples
12 Ports	14 Minutes	103 Samples
16 Ports	18 Minutes 40 Seconds	77 Samples
24 Ports	28 Minutes	51 Samples
32 Ports	37 Minutes 20 Seconds	39 Samples
40 Ports	46 Minutes 40 Seconds	31 Samples

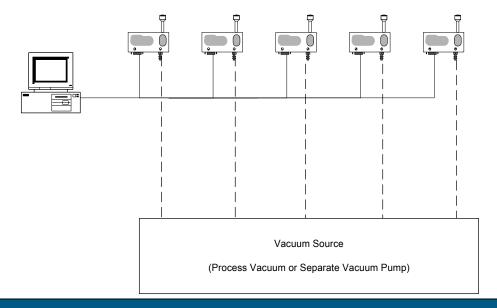
^{*} Based on 1-minute sample, 10 second purge time





Dedicated Remote Particle Counters

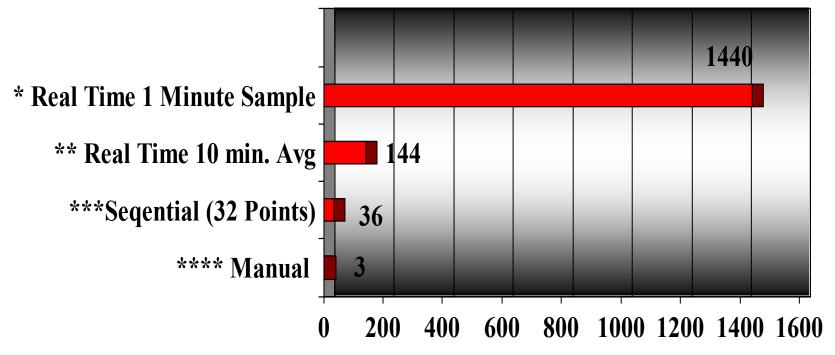
- A. Real-Time Monitoring and Alarming
- B. Sensitivity 0.1 Micron
- C. Catches Every Particle Event
- D. Can Utilize Less Sensitive and Less Expensive Discrete Counters (0.3 μm vs. 0.07 μm) Real Time Particle Monitoring Individual Sensors







Comparison of Counting Techniques (Samples / Day Same Location)



- * 1 Minute Sample Time
- ** Based On Continues Counting And Average Data For 10 minutes
- *** Using 32 Port Sampling System, 1 Minute Sample / Point, 15 Second Purge Step
- **** 1 Sample per Shift





Why Use an FMS System?

REGULATORY COMPLIANCE:

- **★** STATUTORY REQUIREMENTS
- **★ INDUSTRY STANDARDS**
- **★** ISO COMPLIANCE

QUALITY CONTROL:

- **★ YIELD MANAGEMENT**
- **★** RELIABILITY GROWTH
- **★ PROCESS CONTROL**





Benefits of a Cleanroom Facility Monitoring System

Real Time Response – The monitoring system provides early warning when conditions exceed user defined limits. This minimizes environmentally induced yield losses by providing the operators and supervisors with the visibility they need to react to problems in real-time.





Benefits of a Cleanroom Facility Monitoring System

Process Improvement – By correlating cleanroom or process modifications against historical data from the system, better process improvement decisions can be made.

Yield Improvement – Early warning and correlation of events to yield losses helps in improving the manufacturing conditions. This correlation ability also facilitates the analysis of equipment maintenance cycles.





Benefits of a Cleanroom Facility Monitoring System

Proactive Contamination Control – Using an on-line system allows you to take a proactive roll in identifying potentially damaging contamination issues before they happen.

Customer Confidence – An on-line system gives your customer confidence that you are concerned about their products.





Benefits of a Cleanroom Facility Monitoring System

- **Data Correlation** The data from an on-line system allows you to correlate various events and tie them back to yield loss.
- ★ Shift change and particle counts
- ★ Particle counts and yield loss
- ★ Tool operation and particle, TRH and ESD
- ★ Differential pressure and particle
- ★ Humidity and ESD events
- ★ Product transport operations and particle counts





Air Quality in Cleanrooms

Many parameters affect the quality of the air in a clean room or minienvironment

- A. Airborne particle concentration
- B. Temperature and relative humidity
- C. Room and minienvironment pressurization
- D. Air velocity and direction
- E. Airborne Molecular Contamination
- F. Other Factors





Facility Monitoring System Parameters

Monitor Parameters:

Aerosol Particle Counts

Temperature

Relative Humidity

Differential Pressure

Air Velocity

TC, TOC

Conductivity

Electrostatic Discharge

Viable Particle Monitoring / Control

Liquid Particle Counts

WFI Particle / Conductivity







Considerations in System Design

PURPOSE OF THE SYSTEM

- ★ Watch Dog
- ★ Evaluation of Cleanroom Conditions
- **★** Tool For Facilities
- **★** Customer Satisfaction
- ★ Marketing Tool





Considerations in System Design

PARAMETERS TO BE MONITORED: Considerations

- **★** Sensor Sensitivity
- ★ Sensor Scale
- * Sensor Cost
- **★** Sensor Connectivity
- ★ Durability of Sensors for the Application
- ★ Service and Calibration Schedules of the Sensors
- ★ Sensor Location
- ★ Integration of Sensors Into the Cleanroom
- ★ Impact of Installation on Cleanroom





Factors To Consider When Choosing A System

System Management:

- ★ Who Will Be Using The System?
- ★ Who Will Be Managing The System?

Data Collection

- ★ How Will The System Respond To Catastrophic Events?
- ★ How Will The System Generate And Display Alarm Conditions?

Historical Records

- ★ How Will The System Record Incoming Information?
- ★ Will The System Generate Reports to Compare Different Areas at Different Times?





Factors To Consider When Choosing A System

Information Management:

- ★ How Will The System Record Data From The Installed Sensors?
- ★ Will The System Collect Data At A Higher Rate When The Sensor Is In An Alarm Condition And At A Lesser Rate When The Sensor Is In Normal Range?

Manipulation and Access

- ★ How Will The Interact With The User?
- ★ What Type Of Graphical User Interfaces Are Available With The System?
- ★ What Operating System Will The System Run On?
- ★ How Many Users Will Need To See The Data?





Factors To Consider When Choosing A System

Configuration And Expansion:

- What Features Are Available To Assist Users In Configurations, Expanding and Managing The System?
- ★ How Will The System Be Expanded In The Future?
- ★ What Options Are Available to Connect Future Sensor Technology





What to Monitor? Cleanroom:

Cleanroom Conditions (Conditions Related to Cleanroom Operation)

- **★** Aerosol Particle Counts
- ★ Differential Pressure
- **★** Temperature
- ★ Relative Humidity
- ★ Air Velocity
- ★ Air Changes / Per Hour
- ★ Air Handlers or Fan Filter Unit Status
- ★ Air Plenum Return Pressures





What to Monitor? Process:

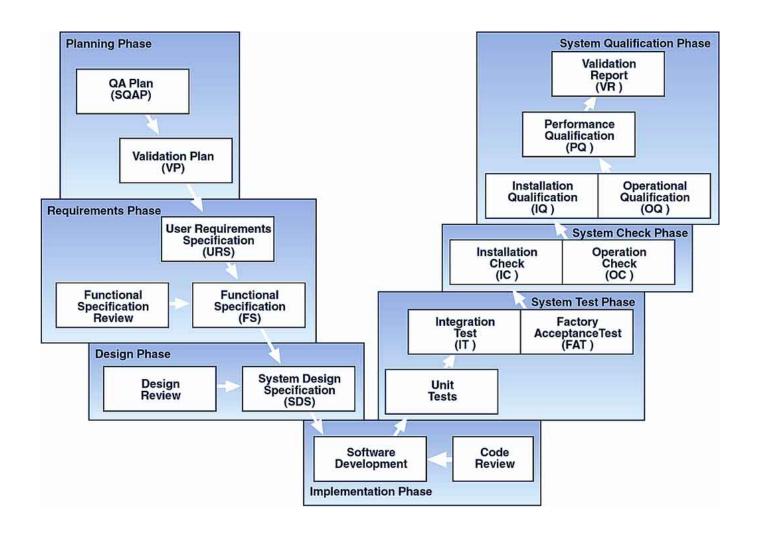
Process Related Conditions (As Related To Products Produced)

- ★ Airborne Molecular Contamination Levels (AMC)
- ★ Electrostatic Charge (Environmental or on Product Surfaces)
- **★** Ionization System Status
- **★** Ground Status
- **★** EMI





SYSTEM DEVELOPMENT LIFE CYCLE • GAMP 4 V-MODEL







Electronic Records and Signatures





Audit Trails

- ★ Provide activity record as required by 21 CFR Part 11
- **★** Entries include
 - → User ID
 - → Date and Time
 - → Type of Action or Event
 - → Previous value
 - → New Value
- ★ System can be set to require user to enter password and insert a comment when
 - → making system changes
 - → acknowledging alarms
- ★ Audit trail log can be printed
- ★ Logs of Alarm, Event or Audit Activities
 - → each log can be separately printed





User Access Controls

- ★ Multi-level permissions
- ★ Unique User ID using Passwords
- ★ Password Aging
- ★ Auto Log out for User Inactivity
- ★ Lock Out of User after Failed Log-ins
- ★ Administrator can DISABLE access by a user
- ★ Separate public NAME used for listing on reports or comment fields





Hardware Supported

- ★ Room-to-room Pressure Differential
- ★ Humidity and Temperature
- ★ Air Velocity
- ★ PLC Inputs and Outputs
 - → Contacts Closures (Doors, events)
 - → Alarm signaling: Light stacks; audible alarms; relays
 - → Analog inputs through PLC (0 to 5 v; 4 to 20 ma)
- ★ Liquid Parameters;
 - → Liquid Particle Counts, TOC, Conductivity, pH, DO, and more
- ★ Airborne Particle Counters
 - → Individual Counters
 - → Manifold / Scanner Multi-point systems
 - → Remote (Fixed) Counters
 - → any combination of the above





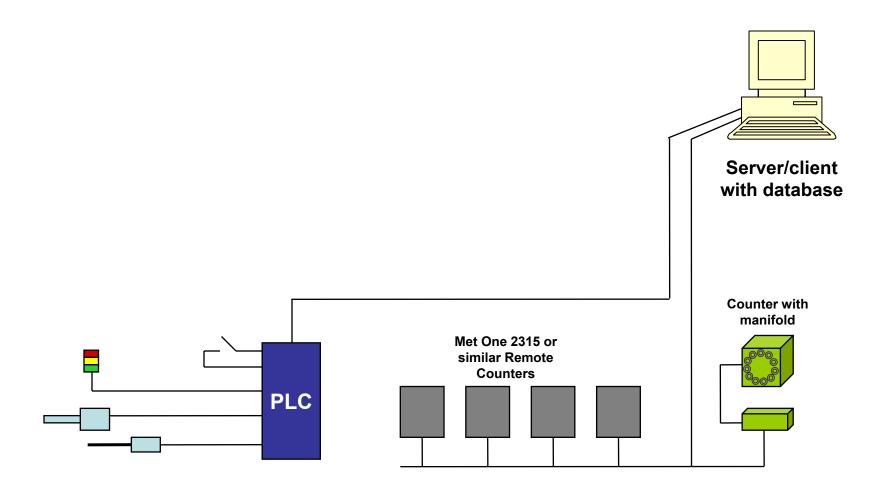
System Configuration Examples

- ★ Standalone system (server/client combined)
- **★** Standalone System with Network Mirror Site
- **★** Simple Networked system
 - → Single server/database with multiple clients
- **★** Complex Networked System
 - → Multiple servers and databases, multiple clients





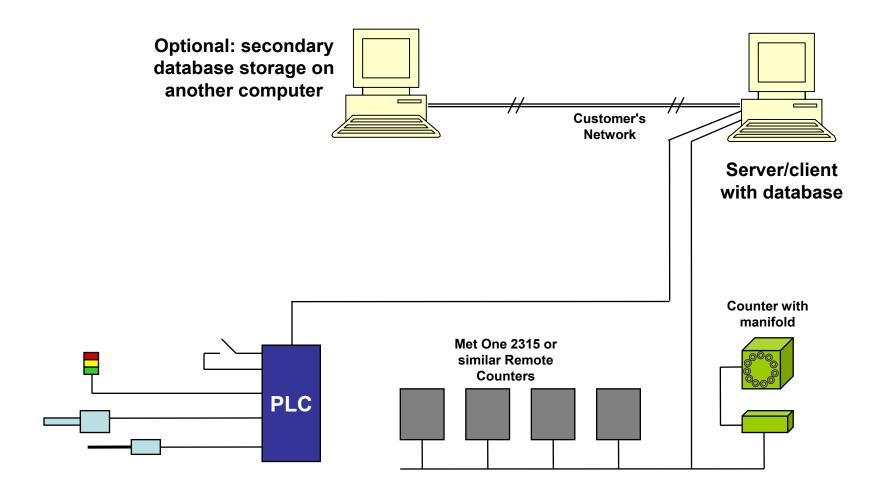
Standalone system (server/client combined)







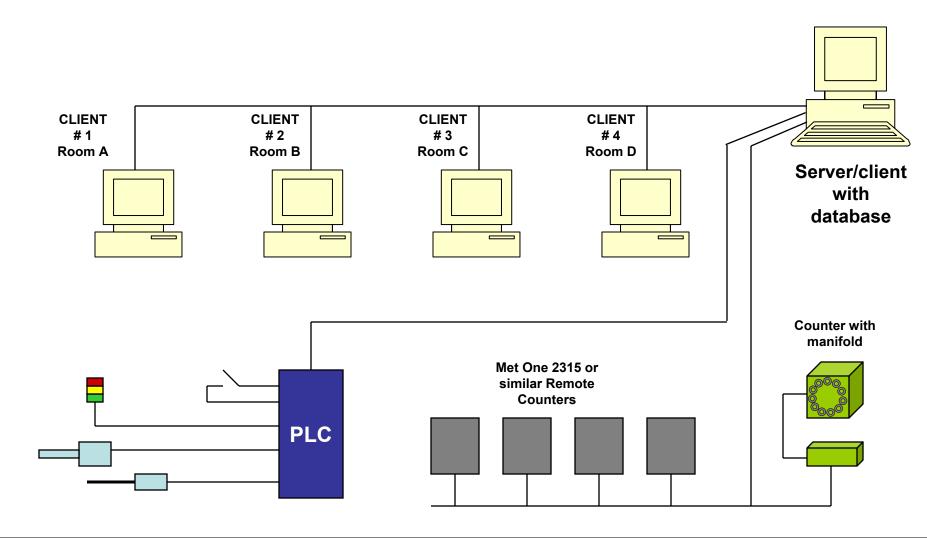
Standalone system with Database Mirror





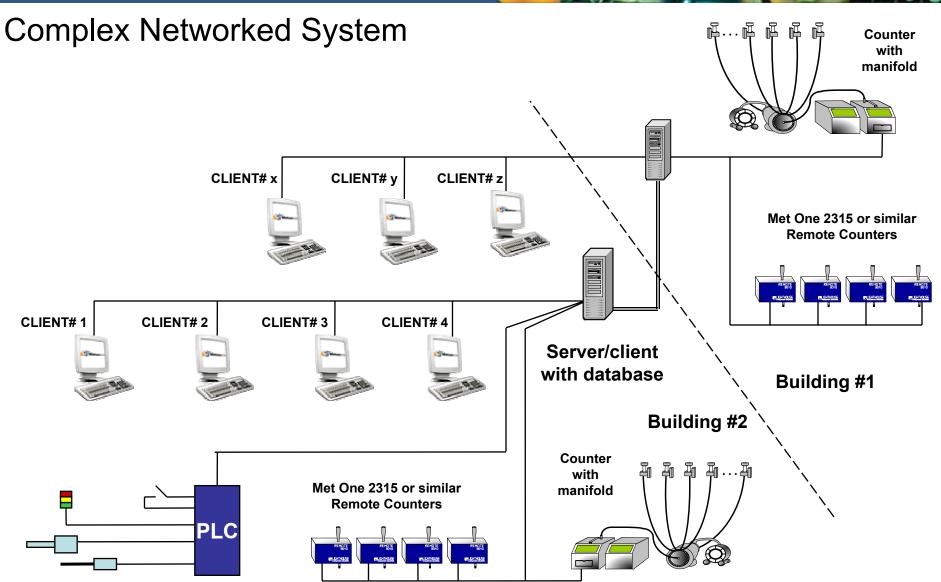


Simple Networked System











Thank You

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